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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: BIELLAK, STEVE; STOKOWSKI, STANLEY E.; VAEZ-IRAVANI, MEHDI  
Assignee: KLA-TENCOR TECHNOLOGIES CORPORATION  
Title: SYSTEM AND METHODS FOR A WAFER INSPECTION SYSTEM USING MULTIPLE ANGLES AND MULTIPLE WAVELENGTH ILLUMINATION  
Serial No.: ~~09/298,007~~ 09/891,693 Filing Date: June 26, 2001  
Examiner: Hoa Q. Pham Group Art Unit: 2877  
Docket No.: M-10693 US

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BOX FEE AMENDMENT  
COMMISSIONER FOR PATENTS  
Washington, DC 20231

RESPONSE TO OFFICE ACTION

Dear Sir:

This responds to the Office Action mailed on January 24, 2002, setting a period for response expiring on April 24, 2002. Attached is a Petition for Extension of Time to extend the response period to expire on July 24, 2002.

IN THE SPECIFICATION

On page 9, paragraph 33, line 5, please add after "channel 420." the following: - In other words, illumination channel 416 is at around zero degrees to a normal direction to surface 426. -- The fully amended paragraph is attached hereto.

IN THE CLAIMS:

Please amend the claims 1, 14, 15, 23, 24, 26, 36, 37, 38, and 42, cancel claims 2 and 30, and add claims 46-85 as follows (a marked-up version showing the changes made is attached hereto):

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